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PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant: Cha Deok Dong)

Serial No.: 10/720,457)

Filed: November 24, 2003)

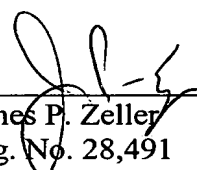
For: METHOD FOR FORMING
DEVICE ISOLATION FILM IN
SEMICONDUCTOR DEVICE)

Group Art Unit: 2822)

Examiner: Michael M. Trihn)

I hereby certify that this paper (or fee) is being
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September 1, 2005


James P. Zeller
Reg. No. 28,491

AMENDMENT "A"

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the specification section begins on page 2 of this paper;
the amendments to the claims section begins on page 3 of this paper; and
the remarks begins on page 9 of this paper.